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Attorney Docket No. XA-10191

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

First Named Inventor: Makoto KOSHIMIZU

Art Unit: 2182

Appln. No.: 10/511,541

Examiner: Kyoung LEE

Filed: October 18, 2004

Confirmation No.: 6425

For: SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF

* * *

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

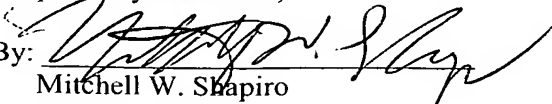
Sir:

In response to the Office Action dated January 26, 2006, and to the requirement for restriction therein, Applicants hereby elect the invention of Group II (Claims 28-40), drawn to a method of making a semiconductor, for examination in this application. Applicants reserve the right to file one or more divisional applications for the non-elected inventions.

An action on the merits with respect to elected Claims 28-40 is respectfully requested.

The Commissioner is hereby authorized to charge to Deposit Account No. 50-1165 any fees under 37 C.F.R. §§1.16 and 1.17 that may be required by this paper and to credit any overpayment to that Account. If any extension of time is required in connection with the filing of this paper and has not been separately requested, such extension is hereby requested.

Respectfully submitted,

By: 
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Date: February 24, 2006

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